

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	4	(324/691.ccls.) and @ad<"20030402" and @pd>"20050426"	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/11/10 12:41
L2	2	(324/649,600.ccls.) and @ad<"20030402" and @pd>"20050426"	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/11/10 12:19
L3	16	(324/750-753.ccls.) and @ad<"20030402" and @pd>"20050426"	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/11/10 12:20
L4	2	(324/692,693.ccls.) and @ad<"20030402" and @pd>"20050426"	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/11/10 12:20
L5	6	(324/719,722.ccls.) and @ad<"20030402" and @pd>"20050426"	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/11/10 12:20
L6	3	(324/439,457,458.ccls.) and @ad<"20030402" and @pd>"20050426"	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/11/10 12:20
L7	5	(204/196,06,228,6,229,8.ccls.) and @ad<"20030402" and @pd>"20050426"	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/11/10 12:21

L8	7	(204/400,556.ccls.) and @ad<"20030402" and @pd>"20050426"	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/11/10 12:21
L9	10	(422/82.02.ccls.) and @ad<"20030402" and @pd>"20050426"	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/11/10 12:22
L10	31	(438/680-683.ccls.) and @ad<"20030402" and @pd>"20050426"	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/11/10 12:22
L11	24	(438/656,676,677,925.ccls.) and @ad<"20030402" and @pd>"20050426"	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/11/10 12:23
L12	2	(438/451,452.ccls.) and @ad<"20030402" and @pd>"20050426"	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/11/10 12:23
L13	44	(324/158.1.ccls.) and @ad<"20030402" and @pd>"20050426"	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/11/10 12:23
L15	4	((molecul\$ ad\$2 conductivity) near2 (check\$3 detect\$3 sens\$3 measur\$5 comput\$3 calculat\$3 \$2valuat\$3 examin\$5 test\$3 determin\$3 recogniz\$3 inspect\$3 anal\$5 monitor\$3 diagnos\$3 identifi\$7 record\$5 meter\$5)) and @ad<"20030402"	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/11/10 13:48
L16	21	((molecul\$ ad\$2 conductivity) with (check\$3 detect\$3 sens\$3 measur\$5 comput\$3 calculat\$3 \$2valuat\$3 examin\$5 test\$3 determin\$3 recogniz\$3 inspect\$3 anal\$5 monitor\$3 diagnos\$3 identifi\$7 record\$5 meter\$5)) and @ad<"20030402"	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/11/10 15:48

L46	1020	(324/76.11.ccls.) and @ad<"20030402"	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/11/10 15:44
L49	42	((molecul\$5 adj2 conductivity) same (check\$3 detect\$3 sens\$3 measur\$5 comput\$3 calculat\$3 \$2valuat\$3 examin\$5 test\$3 determin\$3 recogniz\$3 inspect\$3 anal\$5 monitor\$3 diagnos\$3 identit\$7 record\$5 meter\$5) and @ad<"20030402"	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/11/10 15:29
L51	2	146 and ((self adj assembl\$5 adj mono\$1layer) SAM)	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/11/10 15:56
L52	1	((molecul\$5 adj2 conductivity) and (check\$3 detect\$3 sens\$3 measur\$5 comput\$3 calculat\$3 \$2valuat\$3 examin\$5 test\$3 determin\$3 recogniz\$3 inspect\$3 anal\$5 monitor\$3 diagnos\$3 identit\$7 record\$5 meter\$5) and ((self adj assembl\$5 adj mono\$1layer) SAM) and (surface adj (voltage potential)) and (substrate material \$5film coat\$3 layer sheet pad coat\$3 layer sheet pad wafer film lamina level plane paper web medium media material) and scan\$5 and map\$5).clm.	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/11/10 15:54
L53	1	((molecul\$5 adj2 conductivity) and (check\$3 detect\$3 sens\$3 measur\$5 comput\$3 calculat\$3 \$2valuat\$3 examin\$5 test\$3 determin\$3 recogniz\$3 inspect\$3 anal\$5 monitor\$3 diagnos\$3 identit\$7 record\$5 meter\$5) and ((self adj assembl\$5) SAM) and (surface adj (voltage potential)) and (substrate material \$5film coat\$3 layer sheet pad wafer film lamina level plane paper web medium media material) and scan\$5 and map\$5).clm.	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/11/10 15:57
L54	1	((molecul\$5 adj2 conductivity) and (check\$3 detect\$3 sens\$3 measur\$5 comput\$3 calculat\$3 \$2valuat\$3 examin\$5 test\$3 determin\$3 recogniz\$3 inspect\$3 anal\$5 monitor\$3 diagnos\$3 identit\$7 record\$5 meter\$5) and ((self adj assembl\$5) SAM) and (surface adj (voltage potential)) and (substrate material \$5film coat\$3 layer sheet pad wafer film lamina level plane paper web medium media material) and scan\$5).clm.	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/11/10 15:57
L55	1	((molecul\$5 adj2 conductivity) and (check\$3 detect\$3 sens\$3 measur\$5 comput\$3 calculat\$3 \$2valuat\$3 examin\$5 test\$3 determin\$3 recogniz\$3 inspect\$3 anal\$5 monitor\$3 diagnos\$3 identit\$7 record\$5 meter\$5) and ((self adj assembl\$5) SAM) and (surface adj (voltage potential)) and (substrate material \$5film coat\$3 layer sheet pad wafer film lamina level plane paper web medium media material).clm.	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/11/10 15:59

L56	1	((molecul\$5 adj2 conductivity) and (check\$3 detect\$3 sens\$3 measur\$5 comput\$3 calculat\$3 \$2valuat\$3 examin\$5 test\$3 determin\$3 recogniz\$3 inspect\$3 anal\$5 monitor\$3 diagnos\$3 identit\$7 record\$5 meter\$5) and ((self adj assembl\$5) SAM) and (surface adj (voltage potential))) clm.	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/11/10 16:03
L57	1	((molecul\$5 adj2 conductivity) and ((self adj assembl\$5) SAM) and (surface adj (voltage potential))) clm.	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/11/10 16:05